L Number	Hits	Search Text	DB	Time stamp
1	1196		USPAT;	2003/04/12 15:28
			US-PGPUB;	
			EPO; JPO;	
,	1	(lindium adia ovida) manuf (this adi	DERWENT	2002/04/12 14 15
2	26	((indium adj2 oxide) near5 (thin adj film)) and waveguide\$1	USPAT; US-PGPUB;	2003/04/12 14:16
		IIIM,	EPO; JPO;	
ļ			DERWENT	
3	782	(indium adj tin adj oxide) near5 (thin adj	USPAT;	2003/04/12 15:22
		film)	US-PGPUB;	
			EPO; JPO;	
4	22	((indium adj tin adj oxide) near5 (thin	DERWENT USPAT;	2003/04/12 15:22
"	22	adj film)) and wavequide\$1	US-PGPUB;	2003/04/12 13.22
		adj III,, dila navogalao, i	EPO; JPO;	
			DERWENT	
5	2152	(chromium) near5 (thin adj film)	USPAT;	2003/04/12 15:29
			US-PGPUB;	
			EPO; JPO; DERWENT	
6	47	((chromium) near5 (thin adj film)) and	USPAT;	2003/04/12 15:30
]	waveguide\$1	US-PGPUB;	13.30
			EPO; JPO;	
			DERWENT	
-	282	conductive adj thin adj film adj layer\$1	USPAT;	2003/04/11 17:04
			US-PGPUB;	
			EPO; JPO; DERWENT	
_	116	(conductive adj thin adj film adj layer\$1)	USPAT;	2003/04/11 17:04
		and (oxide)	US-PGPUB;	
			EPO; JPO;	
	^.	//conductive and this and file and	DERWENT	2002/04/11 17-05
-	94	((conductive adj thin adj film adj layer\$1) and (oxide)) and (oxide near10	USPAT; US-PGPUB;	2003/04/11 17:05
		layer\$1)	EPO; JPO;	
		-	DERWENT	
-	19	(((conductive adj thin adj film adj	USPAT;	2003/04/11 17:07
		layer\$1) and (oxide)) and (oxide near10	US-PGPUB;	
		layer\$1)) and (indium adj oxide)	EPO; JPO; DERWENT	
_	3	((((conductive adj thin adj film adj	USPAT;	2003/04/12 13:45
		layer\$1) and (oxide)) and (oxide near10	US-PGPUB;	= 1.15, 51, 12 15, 15
		layer\$1)) and (indium adj oxide)) and	EPO; JPO;	
		waveguide\$1	DERWENT	
-	30193	indium adj2 oxide	USPAT;	2003/04/12 13:47
			US-PGPUB; EPO; JPO;	
			DERWENT	
-	241	(indium adj2 oxide) and (waveguide\$1 near5	USPAT;	2003/04/12 13:47
j		substrate)	US-PGPUB;	
]	:		EPO; JPO;	
	100	(/indium adia orida) and (//	DERWENT	2002/04/12 12:40
-	155	((indium adj2 oxide) and (waveguide\$1 near5 substrate)) and (thin adj film)	USPAT; US-PGPUB;	2003/04/12 13:48
		nears substrace,, and (thin au) limit	EPO; JPO;	
			DERWENT	
-	155	(((indium adj2 oxide) and (waveguide\$1	USPAT;	2003/04/12 13:51
		near5 substrate)) and (thin adj film)) and	US-PGPUB;	
		(oxide)	EPO; JPO;	
_	50	(((indium adj2 oxide) and (waveguide\$1	DERWENT USPAT;	2003/04/12 14:14
	30	near5 substrate)) and (thin adj film)) and	US-PGPUB;	2003/04/12 14:14
		(chromium)	EPO; JPO;	
L			DERWENT	